

Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) 3530US (97-1257)	Application Number N t y t assigned
	Applicant Terry L. Gilt n	
	Filing Date October 23, 1998	Group Art Unit Unknown

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>gag</i>	4,471,647	09/18/84	Jerman et al.	210	198.2	
<i>gag</i>	4,532,700	08/06/85	Kinney et al.	210	200	
<i>gag</i>	4,869,282	09/26/89	Sittler et al.	210	198.2	
<i>gag</i>	4,935,040	06/19/90	Goedert	210	205	
<i>gag</i>	5,132,012	07/21/92	Miura et al.	210	198.2	
<i>gag</i>	5,248,614	09/28/93	Wang	436	7.1	
<i>gag</i>	5,298,767	03/29/94	Shor et al.	204	601	
<i>gag</i>	5,360,759	11/01/94	Stengl et al.	204	450	
<i>gag</i>	5,421,958	06/06/95	Fathauer et al.	204	450	
<i>gag</i>	5,427,648	06/27/95	Pamulapati et al.	204	451	
<i>gag</i>	5,501,787	03/26/96	Bassous et al.	204	601	
<i>gag</i>	5,508,542	04/16/96	Geiss et al.	204	601	
<i>gag</i>	5,571,410	11/05/96	Swedberg et al.	210	198.2	
<i>gag</i>	5,583,281	12/10/96	Yu	210	205	
<i>gag</i>	5,599,759	02/04/97	Inagaki et al.	502	80	
<i>gag</i>	5,663,488	09/02/97	Wang et al.	204	450	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

<i>gag</i>		Stephen C. Terry et al., "A GAS CHROMATOGRAPHIC AIR ANALYZER FABRICATED ON A SILICON WAFER", IEEE Transactions On Electron Devices, Vol. ED-26, No. 12, December 1979, pps. 1880-1886.
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EXAMINER <i>Daniel B. Gabel</i>	DATE CONSIDERED <i>7-14-99</i>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.